

**10/587500**

**AP20 Rec'd PCT/PTO 27 JUL 2006**

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takaaki NODA et al.

Application No.: New U.S. National Phase of  
PCT/JP2005/005699

Filed: July 27, 2006

Docket No.: 128807

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND  
APPARATUS FOR PROCESSING SUBSTRATE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification; and**

**Remarks.**